



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kazuo ICHIKAWA et al.

Application No.: 09/670,877

Filed: September 27, 2000

For: CVD SUBSTRATE AND CLEANING METHOD

MAIL STOP RCE

Group Art Unit: 1763

Examiner: R. Zervigon

Docket No.: 107469

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination.

Applicants further request entry and consideration of the submission filed February 9, 2004.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 151846 in the amount of \$770.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Seth S. Kim
Registration No. 54,577

JAO:SSK/ccs

Date: March 8, 2004

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**DEPOSIT ACCOUNT USE
AUTHORIZATION**
Please grant any extension
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